

Docket No.: 063979-0032



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Yoshiaki HASEGAWA, et al.

Application No.: 10/643,944

Filed: August 20, 2003

Response Under 37 CFR 1.116 - Expedited Procedure

: Customer Number: 20277

: Confirmation Number: 3843

: Group Art Unit: 2828

: Examiner: Tod Thomas VAN ROY

For: SEMICONDUCTOR LASER AND PROCESS FOR MANUFACTURING THE SAME

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.

- ☒ No additional fee is required.
☐ Applicant is entitled to small entity status under 37 CFR 1.27
☐ Also attached:

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	8	21	0	\$50.00 =	\$0.00
Independent Claims	2	8	0	\$200.00 =	\$0.00
Multiple dependent claims newly presented					\$0.00
Fee for extension of time					\$0.00
					\$0.00
Total of Above Calculations					\$0.00

- ☐ Please charge my Deposit Account No. 500417 in the amount of \$0.00.
- ☒ The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Ramyar M. Farid

Registration No. 46,692

Please recognize our Customer No. 20277 as our
correspondence address.

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Date: December 27, 2006



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AMENDMENT UNDER 37 CFR 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated October 27, 2006, having a three-month shortened statutory period for response set to expire January 27, 2007, please amend the above-identified application as follows: